



MAIL STOP AMENDMENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: N.B. Cobb Attorney Docket No.: MEGC121783  
Application No.: 10/696,276 Art Unit: 2123 / Confirmation No.: 6511  
Filed: October 29, 2003 Examiner: J.C. Ochoa  
Title: METHOD AND APPARATUS FOR PERFORMING OPC USING MODEL CURVATURE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

February 8, 2007

TO THE COMMISSIONER FOR PATENTS:

Applicant is aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. X Copies of documents previously submitted as documents Cite No. O3 and O12 are resubmitted and enclosed for the Examiner's convenience.
2. X Pursuant to 37 C.F.R. § 1.97(c), this Information Disclosure Statement is being filed after the period set forth in 37 C.F.R. § 1.97(b) but before the mailing date of a final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution, and is accompanied by:
  - a. \_\_\_\_\_ a certification statement as specified in 37 C.F.R. § 1.97(e); or
  - b. x the submission fee set forth in 37 C.F.R. § 1.17(p).  
Check No. 174024 in the amount of \$180 is enclosed.

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3.   X   The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

CHRISTENSEN O'CONNOR  
JOHNSON KINDNESS<sup>PLLC</sup>



Rodney C. Tullett  
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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first-class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

Date: February 8, 2007 Samela H. Tucker

RCT:pt

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SUPPLEMENTAL INFORMATION CITED BY APPLICANT THAT MAY BE MATERIAL  
TO THE PROSECUTION OF THE SUBJECT APPLICATION

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CURVATURE

U.S. PATENT DOCUMENTS

None

FOREIGN PATENT DOCUMENTS

None

OTHER INFORMATION

(Including Author, Title, Date, Pertinent Pages, Etc.)

\*Examiner Cite  
Initial No.

- 
- \_\_\_\_\_ O3 Previously submitted on 2/5/04 and enclosed for Examiner's convenience:  
Cobb, N., et al., "Mathematical and CAD Framework for Proximity  
Correction," *Proceedings of the International Society for Optical Engineering*  
2726: 208-222, 1996.
- \_\_\_\_\_ O12 Previously submitted on 2/5/04 and enclosed for Examiner's convenience:  
Vacca, A., et al., "Techniques to detect and analyze photomask CD uniformity  
errors," *Proceedings of SPIE, 19th Annual Symposium on Photomask  
Technology, Paper 3873-21*, Pages 209-214, 1999.

Examiner

Date Considered

\_\_\_\_\_  
\*Examiner: Initial if reference considered, whether or not citation is in conformance with  
M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include  
copy of this form with next communication to applicant.

RCT:pt

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